



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

John

**In re patent application of**

David William ABRAHAM, et al.

Serial No.: 10/680,260

Group Art Unit: 2814

Filing Date: October 8, 2003

Examiner: Mai, Anh D.

For: **METHOD AND SYSTEM FOR PATTERNING OF MAGNETIC THIN FILMS  
USING GASEOUS TRANSFORMATION**

**RESPONSE TO FIRST OFFICE ACTION AND  
RESTRICTION REQUIREMENT**

Sir:

In response to the Office Action dated January 31, 2004, please consider the following:

## INTRODUCTORY COMMENTS

**Remarks** begin on page 2 of this paper.